



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 5927

SERIAL NUMBER 09/605,293	FILING or 371(c) DATE 06/28/2000 RULE	CLASS 257	GROUP ART UNIT 2815	ATTORNEY DOCKET NO. MI22-4201		
APPLICANTS DAVID L. CHAPEK, NASHUA, NH; ** CONTINUING DATA ***** NONE J.K. ** FOREIGN APPLICATIONS ***** NONE J.K. ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 07/25/2000						
Foreign Priority claimed <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/JAY C KIM/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance J.K. Initials	STATE OR COUNTRY NH	SHEETS DRAWINGS 4	TOTAL CLAIMS 5	INDEPENDENT CLAIMS 5
ADDRESS Wells St. John P.S. 601 West First Avenue Suite 1300 Spokane, WA 99201-3828 UNITED STATES						
TITLE METHOD FOR CONTROLLING THE MORPHOLOGY OF DEPOSITED SILICON ON A SILICON DIOXIDE SUBSTRATE AND SEMICONDUCTOR DEVICES INCORPORATING SUCH DEPOSITED SILICON						
FILING FEE RECEIVED 846	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees			
			<input type="checkbox"/> 1.16 Fees (Filing)			
			<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)			
			<input type="checkbox"/> 1.18 Fees (Issue)			
			<input type="checkbox"/> Other _____			
			<input type="checkbox"/> Credit			